

Mayer, Fortkort & Williams, PC
251 North Avenue West. 2nd Floor
Westfield, NJ 07090

Fax Cover Sheet

DATE:	October 13, 2003	PAGES:	14 (fourteen) w/cover
TO:	Examiner Angel Roman GAU 2812	PHONE:	(703) 306-0207
		FAX:	(703) 872-9318
FROM:	Karin L. Williams Mayer, Fortkort & Williams, PC	PHONE:	(908) 518-7700
		FAX:	(908) 518-7795

Message

DOCKET GS149

Please see attached: Amendment

RECEIVED
CENTRAL FAX CENTER

OCT 14 2003

OFFICIAL

CONFIDENTIALITY NOTICE

This facsimile transmission is intended only for the use of the addressee and may contain confidential information which is protected by the attorney/client privilege. If you are not the recipient, you are hereby notified that any disclosure, copying,

Patent Application
10/010,162

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Fwu-Iuan Hshieh et al.
Serial No.: 10/010,162
Filed: November 20, 2001
Title: Method Of Forming Narrow Trenches In Semiconductor Substrates
Art Unit: 2812
Examiner: Angel Roman
Docket No.: GS 149

Via Facsimile 703-872-9318

Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

RECEIVED
CENTRAL FAX CENTER

OCT 14 2003

OFFICIAL

AMENDMENT

Sir:

In response to the Office Action dated July 11, 2003 (Paper No. 7), the time for response ending on Tuesday, October 14, 2003 (Monday October 13 being a Federal Holiday), kindly amend the above-identified application as follows. In addition, any deficiencies may be charged to deposit account No. 50-1047.